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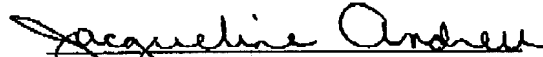
## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric Bornstein  
Application Serial No.: 10/776,106  
Filing Date: 11 February 2004  
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER  
SYSTEM  
Examiner: Shay, David M.  
Art Unit: 3735  
Atty. Docket No.: 072287-0020  
Confirmation No.: 2676

## CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted (571-273-8300) to the USPTO, on the date indicated below.

Date: 4 December 2007

  
Jacqueline Andreu

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## AMENDMENT

This paper is in response to the non-final Office Action dated 02 November 2007 for the above-identified application. The Applicant requests reconsideration and further examination be in light of the following:

- **Amendments to the Claims**, as listed in the listing of claims beginning on page 2 of this paper; and
- **Remarks**, beginning on page 13 of this paper.